

Appl. No. 10/099,840



Handwritten notes: #4 and #4, KDuncan, 5/21/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.10/099,840
Filing Date March 12, 2002
Inventor James J. Hofmann
Assignee Micron Technology, Inc.
Group Art Unit 2818
Examiner Hoang, Quoc Dinh
Attorney's Docket No.MI22-1803
Title: "Methods of Forming Patterns for Semiconductor Constructions; and Molds
Configured to Patterned Masses Associated with Semiconductor Constructions"

RESPONSE TO APRIL 24, 2003 OFFICE ACTION

To: Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

None.

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